## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Y. SHIMADA, et al.

Application No.:

**TBD** 

Filed:

January 18, 2005

For:

MULTILAYER WIRING BOARD, MANUFACTURING METHOD

THEREOF, SEMICONDUCTOR DEVICE, AND WIRELESS

**ELECTRONIC DEVICE** 

Group:

**TBD** 

Examiner:

**TBD** 

## **PRELIMINARY AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

January 18, 2005

Sir:

Please amend the above-identified application, prior to calculation of the filing fee, as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.